TRANSMITTAL OF INFORMATION DISCLOSURE STATEMENT Docket No. (Under 37 CFR 1.97(b) or 1.97(c)) 128834-2 In Re Application Of: Borst et al. Group Art Unit Confirmation No. Customer No. Application No. Filing Date Examiner 3383 23413 1775 08/07/2003 Xu, Ling X. 10/638,094 TEDIUM AND METHOD FOR THE PREPARATION THEREOF Title: **DATA** Address to: **Commissioner for Patents** P.O. Box 1450 Alexandria, VA 22313-1450 37 CFR 1.97(b) The Information Disclosure Statement submitted herewith is being filed within three months of the filing of a national application other than a continued prosecution application under 37 CFR 1.53(d); within three months of the date of entry of the national stage as set forth in 37 CFR 1.491 in an international application; before the mailing of a first Office Action on the merits, or before the mailing of a first Office Action after the filing of a request for continued examination under 37 CFR 1.114. 37 CFR 1.97(c) 2. The Information Disclosure Statement submitted herewith is being filed after the period specified in 37 CFR 1.97(b), provided that the Information Disclosure Statement is filed before the mailing date of a Final Action under 37 CFR 1.113, a Notice of Allowance under 37 CFR 1.311, or an Action that otherwise closes prosecution in the application, and is accompanied by one of: ☐ the statement specified in 37 CFR 1.97(e); OR ☑ the fee set forth in 37 CFR 1.17(p). 04/06/2006 CNGUYEN2 00000004 503619 01 FC 1806 180.00 DA

TRANSMITTAL OF INFORMATION DISCLOSURE STATEMENT (Under 37 CFR 1.97(b) or 1.97(c))					Docket No. 128834-2	
In Re Application o	f: Borst et al.					
Application No.	No. Filing Date Examiner Customer No. Group Art Unit Confi		Confirmation No.			
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For:	DATA STORAGE MEDIUM)
	AND METHOD FOR THE)
	PREPARATION THEREOF)

INFORMATION DISCLOSURE STATEMENT UNDER 37 CFR §§ 1.56, 1.97 AND 1.98

Commissioner for Patents P. O. Box 1450 Alexandria, VA 22313-1450

Sir:

In compliance with the duty to disclose, submitted herewith is form PTO-A820 (PTO-1449) listing publication(s) of which those designated by 37 CFR § 1.56 are aware. Copies of the non-United States patents or published applications are enclosed.

The filing of this Information Disclosure Statement shall not be construed as a representation that a search has been made, or an admission that the information cited is, or is considered to be, material to patentability.

Respectfully submitted,

CANTOR COLBURN LLP

J. Michael Buchanan

Registration No. 44,571

Date: April 3, 2006 Customer No. 23413

Telephone No. (860) 286-2929

PTO-1449			Attorney's Docket Number 128834-1	Serial Number 10/638,094				
INFORMATION DISCLOSURE STATEMENT BY APPLICANT LIST OF ITEMS APP 0.5 2006			Name of Applicant Borst et al.					
		Filing Date	Group Art					
(Use several sheets if necessary) 08/07/2003 1775								
Examiner Initial	Document Number	Date	NAME	Class	Subclass	Filing Date If Appropriate		
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